

DO NOT ENTER: /E.S./

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Sun-Uk Kim et al.                      Art Unit : 1791  
Serial No. : 10/560,023                              Examiner : Erin Lynn Snelting  
Filed : December 8, 2005                          Conf. No. : 1005  
Title : Method For Fabricating A Porous Silica Sphere

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO FINAL ACTION OF NOVEMBER 13, 2009

Please amend the above-identified application as follows: